Docket No.: 4468-017



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

KIMURA, EIJI

Serial No. 09/877,202

Filed: June 11, 2001

For: OPTICAL CHARACTERISTICS MEASURING APPARATUS, METHOD AND

RECORDING MEDIUM

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D. C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

PATENT

Group Art Unit: 2810

Examiner: N/A

The attached references were cited in the Combined Search and Examination Report issued in connection with the corresponding British application.

Respectfully submitted

LOWE HAUPTMAN GILMAN & BERNER, LLP

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Date: August 22, 2002

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BJH:JK

INFORMATION DISCLOSURE			ATTY. DOCKE 4468-017	ATTY. DOCKET NO. 4468-017		SERIAL NO. 09/877,202	
CITATION IN AN				KIMURA, EIJI et al			
2 2002 ·	(PTO-1	FILING DATE June 11, 20	FILING DATE June 11, 2001		GROUP 2810		
2.10		U.S. PATEN	T DOCUMENTS				
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	4,551,019	11/1985	Vella et al				
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EXAMINER'S		FOREIGN PATENT DOCUMENTS		·	T T	Translatio	
INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Yes	
	WO99/43054	8/1999	WIPO				
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

EXAMINER

DATE CONSIDERED

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)